

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of)
SUZUKI et al.)
Application Number: To Be Assigned)
Filed: Concurrently Herewith)
For: AN IMAGE DISPLAY AND A DRIVING)
METHOD OF THE SAME)

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

This Information Disclosure Statement is submitted with the initial application. Accordingly, no fee is due or payable at this time.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 08-1480.

Respectfully submitted,



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Form PTO 1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	ATTY. DOCKET NUMBER NITT.0057		SERIAL NUMBER 3e Assigned
	APPLICANT SUZUKI et al.		
	FILING DATE Concurrently Herewith	GROUP	

U.S. Patent Documents

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBC CLASS	FILING DATE

Foreign Patent Documents

Examiner Initial		DOCUMENT NUMBER	FILING DATE	COUNTRY	CLAS S	SUB- CLASS	TRANSLATION	
							YES	NO

Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)

		Kuniyoshi Yokoo, Hiroshi Tanaka, Shinji Sato, Junichi Murota, and Shoichi Ono, "Emission Characteristics of Metal-Oxide-Semiconductor Electron tunneling Cathode", J. Vac. Sci. Technol. B 11(2), Mar/Apr 1993, pp. 429-432
		Nobuyasu Negishi, Takashi Chuman, Shingo Iwasaki, Takamasa Yoshikawa, Hiroshi Ito and Kiyohide Ogasawara, "High Efficiency Electron-Emission in Pt/SiO _x /Si/Al Structure", Jpn. J. Appl. Phys. Vol 36 (1997), 15 July 1997, pp. 939-941
		Nobuyoshi Koshida, Tsuyoshi Ozaki, Xia Sheng, and Hideki Koyama, "Cold Electron Emission from Electroluminescent Porous Silicon Diodes", Jpn. J. Appl. Phys. Vol 34 (1995), 1 June 1995, pp. 705-707.
EXAMINER		DATE CONSIDERED

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant